

BAR CODE LABEL



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430

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APPLICANT

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CONTINUING DATA***

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STATE OR
COUNTRY

CA

SHEETS
DRAWING

7

TOTAL
CLAIMS

20

INDEPENDENT
CLAIMS

3

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\$710.00

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TITLE

METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR
FABRICATION PROCESSThis is to certify that annexed hereto is a true copy from the records of the United States
Patent and Trademark Office of the application which is identified above.By authority of the
COMMISSIONER OF PATENTS AND TRADEMARKS

Date

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